#### AMENDMENTS TO THE CLAIMS

Claim 11 (currently amended):

A method for materials processing by means of plasmainducing high-energy radiation, including laser radiation, in
which wherein instantaneous intensity of the radiation is
measured at plural locations of a vapor capillary, characterized
in-that established by the radiation, and wherein shapes of two
spaced-apart peak-intensity regions (10,12) of the radiation
emitted from the vapor capillary, and of a minimum region (11)
that is formed between the two peak-intensity regions of extreme
values, are detected metrologically. metrologically
Metrologically detected shapes of the peak-intensity regions of
extreme values are compared with predetermined region shapes,
and control of the a materials processing operation takes place
as a function of deviations of the detected shapes from the
predetermined region shapes.

Claim 12 (currently amended):

The method as recited in claim 11, <del>characterized in that</del> wherein control of the materials processing operation takes

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place when the shape of the minimum region (11) deviates form from a predetermined near-circular region shape.

## Claim 13 (currently amended):

The method as recited in claim 11, characterized in that wherein control of the materials processing operation takes place when there are sharp regional boundaries in the regions (10',12') of transition from the shape of the minimum region (11) to the shapes of the peak regions (10,12).

## Claim 14 (currently amended):

The method as recited in claim 11, characterized in that wherein control of the materials processing operation takes place when the shape of one of the three regions of extreme values—deviates from a predetermined region shape.

#### Claim 15 (currently amended):

The method as recited in claim 11, characterized in that wherein control of the materials processing operation takes place when the shape of a peak-intensity region (10) that is in

133

a leading position, in a feed direction (14), with respect to a workpiece moving relative to the radiation, and the shape of the trailing peak region (12), deviate from predetermined region shapes.

# Claim 16 (currently amended):

The method as recited in claim 11, characterized in that wherein control of the materials processing operation takes place when the deviation in shape exceeds either of a predetermined difference in magnitude and a predetermined difference in duration.

## Claim 17 (currently amended):

The method as recited in claim 11, characterized in that wherein control of the materials processing operation takes place as a function of angular positions assumed by a straight line (13) passing through the peak-intensity regions (10,12) relative to a feed direction (14) of a workpiece being processed and moving relative to the plasma-inducing radiation.

Claim 18 (currently amended):

The method as recited in claim 11, characterized in that wherein control of the materials processing operation takes place when sporadically occurring, intensely radiating light spots (22) are detected in a region of measurement—that is metrologically detecting the shapes of the regions of extreme values.

Claim 19 (currently amended):

The method as recited in claim 11, characterized in that wherein control of the materials processing of workpieces of different thicknesses takes place when the minimum region (11) deforms the peak region (10,12) that is in one of a leading and trailing position in a feed direction.

Claim 20 (currently amended):

The method as recited in claim 11, characterized in that wherein control of the materials processing operation takes place when two submaxima (15,16), present on both sides of a joint path in a peak region (10) that is in a leading position in a feed direction, deviate from a predetermined symmetry.

Claim 21 (new):

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A method for welding by high-energy plasma-inducing radiation, the method comprising the steps of:

directing the high-energy plasma-inducing radiation at a selected weld area to effect in the weld area a radiation intensity which forms a vapor capillary;

operating sensor means to measure the intensity of radiation at two spaced apart peak intensity regions of radiation emitted from the vapor capillary and a minimum intensity region formed between the first and second peak intensity regions;

comparing the measurements obtained by the sensor means with selected predetermined data; and

modifying the intensity of the high-energy plasma-inducing radiation to substantially match measurements obtained by the sensor means with the predetermined data.